	Search Text	DBs
-		US-PGPUB;
	dielectric same heating same teflon same	USPAT; EPO;
1	microwave	JPO; DERWENT;
1	inite to wave	IBM TDB
-		US-PGPUB;
		USPAT; EPO;
2	dielectric same heating same teflon	JPO; DERWENT;
		IBM TDB
<u></u>		
		US-PGPUB; USPAT; EPO;
3	3 and teflon	1 ' '
		JPO; DERWENT;
		IBM_TDB
		US-PGPUB;
4	dielectric same heating same susceptor	USPAT; EPO;
		JPO; DERWENT;
		IBM_TDB
		US-PGPUB;
5	(microwave or radio-frequency or rf or	USPAT; EPO;
	dielectric) same heating same susceptor	JPO; DERWENT;
		IBM_TDB
1		US-PGPUB;
6	5 and teflon	USPAT; EPO;
		JPO; DERWENT;
		IBM_TDB
	(microwave or radio-frequency or rf or	US-PGPUB;
7	dielectric) same (sinter\$3 or heat\$3)	USPAT; EPO;
'	same susceptor	JPO; DERWENT;
	same susceptor	IBM_TDB
		US-PGPUB;
8	7 and teflon	USPAT; EPO;
	and terron	JPO; DERWENT;
		IBM_TDB
	/	US-PGPUB;
9	(microwave or radio-frequency or rf or	USPAT; EPO;
٠	dielectric) same (sinter\$3 or heat\$3 or	JPO; DERWENT;
L	weld\$3 or seal\$3) same susceptor	IBM_TDB
	(microwave or radio-frequency or rf or	US-PGPUB;
10	dielectric) same (sinter\$3 or heat\$3 or	USPAT; EPO;
10	weld\$3 or seal\$3) same susceptor same	JPO; DERWENT;
	teflon	IBM_TDB
		US-PGPUB;
11	0 and basiles	USPAT; EPO;
	9 and teflon	JPO; DERWENT;
		IBM TDB
		US-PGPUB;
12		USPAT; EPO;
	teflon near5 (weld\$3 or seal\$3)	JPO; DERWENT;
		IBM TDB
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	Search Text	DBs
		US-PGPUB;
13		USPAT; EPO;
	teflon near2 (weld\$3 or seal\$3)	JPO; DERWENT;
		IBM TDB
		US-PGPUB;
	(teflon near2 (weld\$3 or seal\$3)) same	USPAT; EPO;
14	(loss near5 (tangent or factor))	JPO; DERWENT;
		IBM TDB
<u> </u>		US-PGPUB;
		USPAT; EPO;
15		
	(microwave or dielectric)	JPO; DERWENT;
ļ		IBM_TDB
	teflon near5 sintering	US-PGPUB;
16		USPAT; EPO;
	Į ,	JPO; DERWENT;
		IBM_TDB
	(microwave or radio-frequency or rf or	US-PGPUB;
17	dielectric) same (sinter\$3 or heat\$3 or	USPAT; EPO;
	weld\$3 or seal\$3) same teflon	JPO; DERWENT;
		IBM_TDB
	(microwave or radio-frequency or rf or	US-PGPUB;
18	dielectric) same (sinter\$3 or heat\$3 or	USPAT; EPO;
	weld\$3 or seal\$3) same teflon same	JPO; DERWENT;
	susceptor	IBM_TDB
	((polytetrafluoroethylene or teflon)	US-PGPUB;
19	near5 sintering) same susceptor same	USPAT; EPO;
	(dielectric or microwave)	JPO; DERWENT;
	(drefederic of microwave)	IBM_TDB
	((polytetrafluoroethylene or teflon)	US-PGPUB;
20	near5 sintering) and (susceptor same	USPAT; EPO;
	(dielectric or microwave))	JPO; DERWENT;
	(distribution of mission of)	IBM_TDB
		US-PGPUB;
21	((polytetrafluoroethylene or teflon)	USPAT; EPO;
	near5 sintering)	JPO; DERWENT;
		IBM_TDB
		US-PGPUB;
22	21 and vacuum	USPAT; EPO;
		JPO; DERWENT;
	·	IBM_TDB
		US-PGPUB;
23	21 and (vacuum same (pore or porosity or	USPAT; EPO;
23	porous))	JPO; DERWENT;
		IBM_TDB
		US-PGPUB;
24	21 and (vacuum near5 heat\$3) and (pore or	USPAT; EPO;
	porosity or porous)	JPO; DERWENT;
		IBM TDB
	<u> </u>	<u> </u>

	Search Text	DBs
25	(microwave or radio-frequency or rf or dielectric) same (sinter\$3 or heat\$3 or weld\$3 or seal\$3) same vacuum	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
26	27 and (vacuum same (pore or porosity or porous))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
27	28 and (polytetrafluoroethylene or teflon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
28	(teflon or polytetrafluoroethylene) and (dielectric or microwave or radio-frequency or rf) and sinter\$3	USOCR; FPRS
29	(teflon or polytetrafluoroethylene) and (dielectric or microwave or radio-frequency or rf) and sinter\$3 and vacuum	USOCR; FPRS
30	(rubber same nitrile same porous) same (teflon or polytetrafluoroethylene)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB
31	(rubber same nitrile same porous same membrane) same (teflon or polytetrafluoroethylene)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM TDB
32	(microwave or radio-frequency or rf or dielectric) same (sinter\$3 or heat\$3 or weld\$3 or seal\$3) same vacuum	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
33	(microwave or radio-frequency or rf or dielectric) same sinter\$3 same vacuum same porous	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
34	teflon same sinter\$3 same vacuum same porous	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
35	teflon same sinter\$3 same vacuum	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB

36	sintering	near5	vacuum	near5	teflon	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM TDB
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	Search Text	DBs
37	(264/125,126,127).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
38	45 and 46	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
39	46 and vacuum	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
40	46 and (vacuum near5 sintering)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
41	(264/101,102).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
42	46 and 52	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
43	(264/491,489,490).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
44	46 and (vacuum near5 heat\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
45	45 and sinter\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB
46	55 and vacuum	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB